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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application Serial No. .... 10/072,440  
Confirmation No. .... 2639  
Filing Date ..... February 5, 2002  
Inventor..... H. Daniel Dulman  
Assignee..... Micron Technology, Inc.  
Group Art Unit..... 1756  
Examiner ..... Stephen D. Rosasco  
Attorney's Docket No. .... MI22-1829  
Customer No. .... 021567  
Title: Radiation Patterning Tools, And Methods Of Forming Radiation Patterning Tools

**PRELIMINARY AMENDMENT TO ACCOMPANY RCE FILING**

To:           Mail Stop 313(c)  
              Commissioner for Patents  
              P.O. Box 1450  
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**AMENDMENTS**